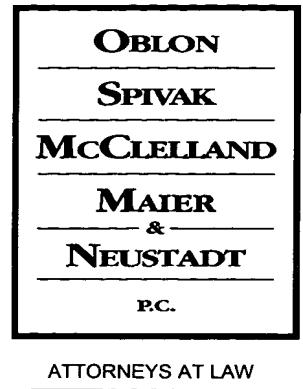




Docket No.: 237457US90CONT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313



RE: Application Serial No.: 10/615,950
Applicants: Yasuji HIRAMATSU, et al.
Filing Date: July 10, 2003
For: CERAMIC SUBSTRATE FOR SEMICONDUCTOR
FABRICATING DEVICE
Group Art Unit:
Examiner:

SIR:

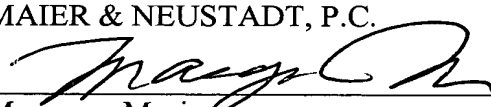
Attached hereto for filing are the following papers:

**Submission of Supplemental Application Data Sheet
Supplemental Application Data Sheet (2)**

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.


Masayasu Mori

Registration No. 47,301



22850

(703) 413-3000 (phone)
(703) 413-2220 (fax)
H:\237457\SHORT_CVR_SUPPLEADS.DOC